



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

November 20, 2025

IGI Report Number **LG750527537**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **CUSHION MODIFIED BRILLIANT**

Measurements **11.36 X 8.16 X 5.49 MM**

GRADING RESULTS

Carat Weight **4.09 CARATS**

Color Grade **F**

Clarity Grade **VS 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

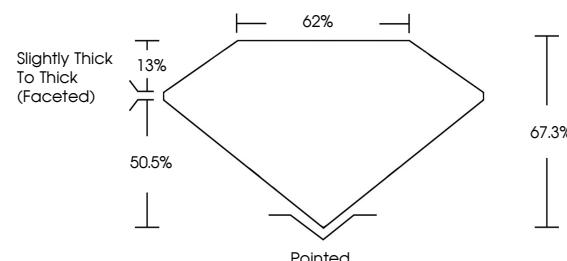
Fluorescence **NONE**

Inscription(s) **IGI LG750527537**

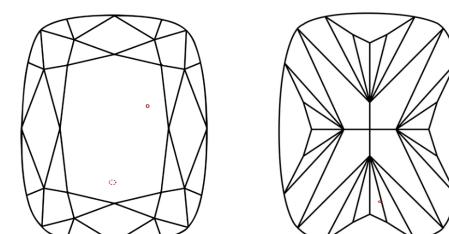
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

www.igi.org

LG750527537
Report verification at igi.org

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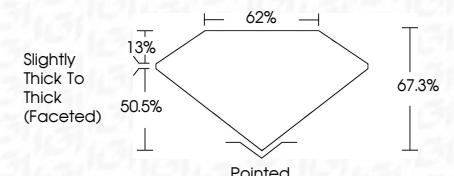
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Sample Image Used



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November 20, 2025

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CUSHION MODIFIED BRILLIANT

11.36 X 8.16 X 5.49 MM

4.09 CARATS

F

VS 1

67.3%

62%

50.5%

Slightly Thick To Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

None

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Type IIa

IGI